Search Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/650,601	LIN, SHI-CHI
Examiner	Art Unit
José R. Díaz	2815

SEARCHED				
Class	Subclass	Date	Examiner	
			:	
	-			

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NO (INCLUDING SEARCH	STRATEGY)
	DATE	EXMR
Text Search. See search history printout.	10/2/2005	JRD